

Notice of References Cited		Application/Control No. 10/078,284	Applicant(s)/Patent Under Reexamination VANHAELEMEERSCH ET AL.	
		Examiner Michelle Estrada	Art Unit 2823	Page 1 of 1

U.S. PATENT DOCUMENTS

*	Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
A	US-6,329,290	12-2001	Zhao, Bin	438/700
B	US-6,410,437	06-2002	Flanner et al.	438/689
C	US-6,037,257	03-2000	Chieng et al.	438/687
D	US-6,300,236	10-2001	Harper et al.	438/618
E	US-5,674,787	10-1997	Zhao et al.	438/627
F	US-2002/0119664	08-2002	Annapragada et al.	438/700
G	US-2002/0106895	08-2002	Chung, Wei-Ming	438/687
H	US-6,518,174	02-2003	Annapragada et al.	438/637
I	US-			
J	US-			
K	US-			
L	US-			
M	US-			

FOREIGN PATENT DOCUMENTS

*	Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
N					
O					
P					
Q					
R					
S					
T					

NON-PATENT DOCUMENTS

*	Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)	
U		
V		
W		
X		

*A copy of this reference is not being furnished with this Office action (See MPEP § 707.05(a))
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.